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Windowless microfluidic platform based on capillary burst valves for high intensity x-ray measurements

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We propose and describe a microfluidic system for high intensity x-ray measurements. The required open access to a microfluidic channel is provided by an out-of-plane capillary burst valve (CBV). The functionality of the out-of-plane CBV is characterized with respect to the diameter of the windowless access hole, ranging from 10 to 130 μm. Maximum driving pressures from 22 to 280 mbar corresponding to refresh rates of the exposed sample from 300 Hz to 54 kHz is demonstrated. The microfluidic system is tested at beamline ID09b at the ESRF synchrotron radiation facility in Grenoble, and x-ray scattering measurements are shown to be feasible and to require only very limited amounts of sample, <1 ml/h of measurements without recapturing of sample. With small adjustments of the present chip design, scattering angles up to 30° can be achieved without shadowing effects and integration on-chip mixing and spectroscopy appears straightforward.


I. INTRODUCTION

The past decade has seen considerable advances within the time-resolved synchrotron-based studies of chemistry and biology in solution, spanning from fundamental chemistry on the 100 ps time scale to conformation changes in solvated proteins on the microsecond scale.1 In both of these time regimes, the arrival of the new x-ray free electron laser (XFEL) sources is foreseen to greatly increase the amount of information that can be extracted from liquid-state experiments due to the exceptional brilliance, time resolution, and coherence properties.2

In order to take full advantage of the possibilities offered by the new x-ray sources, some crucial points in sample handling will have to be addressed to preserve coherence, subpicosecond time resolution, and to prevent sample damage from the extremely bright x-ray pulse as the x-ray figure-of-merit, brilliance (brilliance is defined as photons/s/mrad2 mm2 0.1% bandwidth), increases by ten orders of magnitude over current synchrotron sources. To prevent sample damage and debris buildup, the liquid sample should ideally be replaced between every x-ray pulse, which will come at 120 Hz at the Linac Coherent Light Source (LCLS) at Stanford and at 10Hz/5MHz at the European XFEL. Preserving the pulse-length limited time resolution dictates that the sample must be thin due to the difference in light speed between the UV-VIS-infrared laser pump pulse and the x-ray probe pulse as they propagate through the sample. The accumulated time difference \( \Delta t \) between the two pulses is given by \( \Delta t = l/c(1-n) \), with \( l \) the path length, \( c \) the speed of light, and \( n \) the refractive index of the media at a given pump pulse wavelength. Taking water (\( n=1.33 \)) as a typical example, a path length of 100 μm corresponds to a time delay between the pulses slightly larger than 100 fs thus limiting the sample thickness to 50–100 μm if 100 fs time resolutions is to be conserved in the case of copropagating pump and probe beams.3 Such sample dimensions are routinely achieved in microjet systems4,5 and droplet shooters,6 however, the curved interfaces inherent in these systems may cause refraction effects as well as decrease the coherence properties of the x-ray beam. Free-flowing films7 with planar interfaces perpendicular to the x-ray beam may also reach the required maximum thickness but as well as stability, lack of vacuum compatibility, and large sample volumes are known issues. Finally, cuvette-based systems8 might not be able to withstand the x-ray beam due to the significant energy deposited by absorption.

Taking all of the points above into consideration, an ideal sample system for XFEL measurements on liquid systems will have a thin (sub-75 μm) and stable sheet of liquid flowing perpendicular to the x-ray beam. The flow velocity of the sample should furthermore be sufficient to reach a refresh rate of the exposed volume exceeding the repetition frequency of the x-ray pulses (10 Hz/120 Hz/5 MHz) while also ensuring that no material other than the sample should be in the x-ray beam path. In the following, we present a windowless, microfluidic sample chip based on an out-of-plane implementation of the capillary burst valve (CBV) principle that meets these demands. The proposed design also enables straightforward integration of other lab-on-a-chip applications, such as waveguides, lasers,9 mixers,10 and separators.11

The functionality of the windowless x-ray access hole in the proposed microfluidic platform is based on a CBV, sug-
suggested and tested earlier. CBVs rely on the surface tension of the liquid at a liquid/solid/gas interface and it consists of a narrow channel with a sudden widening at a given point along its length—the following description represents liquid in a hydrophilic channel. When a liquid reservoir is brought into contact with the narrow channel, the liquid is dragged into the channel by capillary forces. The liquid propagates along its length—the following description represents liquid of a narrow channel with a sudden widening at a given point and 1.

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Originally, the burst pressure has been predicted and confirmed to be proportional to the liquid surface tension $\gamma$ and inversely proportional with the channel dimension $D$. The bursting pressure for a hydrophilic or hydrophobic channel with circular cross section can be derived from the Young–Laplace equation, and is given by Eq. (1).

$$\Delta p_b = -\frac{4 \gamma \cos \theta_{cb}}{D}. \quad (1)$$

In previous demonstrations, the CBV has been placed in the plane of the microfluidic network, e.g., for use in microfluidic centrifugal systems. Employing a CBV perpendicular to the direction of the sample has not been implemented previously and in the following it will be described how this enables windowless microfluidic measuring platforms.

The microfluidic chip presented in this work has channels in the surface of the chip and a perpendicular windowless access hole through the bulk, as illustrated in Figs. 1(c) and 1(d).

**II. DESIGN AND FABRICATION OF THE WINDOWLESS MICROFLUIDIC DEVICE**

As Fig. 2 illustrates, the microfluidic sample cell is designed with two inlet channels merging into a 1-cm-long straight channel which terminates in two outlet channels identical to the inlets. All channels are 300 $\mu$m wide and 78 $\mu$m deep. In the middle of the straight channel the CBV is positioned. Figure 2(b) illustrates a top view of the device layout with a closeup of the CBV region in the inset. The large circle indicates the backside hole and the small circle indicates the windowless access hole. The diameter of the large backside hole of the CBV is kept constant at 200 $\mu$m but can be arbitrarily increased for better beam access. The diameter of the window itself is varied from 10 to 130 $\mu$m and the thickness of the window membrane is 25 $\mu$m in the substrate wafer and 40 $\mu$m in the lid wafer. For x-ray measurements the thickness of the window membrane should be minimized as much as possible as stagnant fluid in this volume will not be exchanged and may give rise to spurious background signals as discussed in further detail below.

The microfluidic devices are fabricated using planar silicon (Si) microfabrication techniques. 500 $\mu$m thick, double polished, single crystalline (100) Si wafers are used. The fabrication consists of three masking steps. Each step employs a deep reactive ion etch (DRIE) utilizing the Bosch process, thereby transferring the structures anisotropically into the Si wafer. All masking steps are illustrated in Fig. 2(a). In each of the three steps, I-line UV contact lithography is used to transfer the mask layout into an 10-$\mu$m-thick UV sensitive resist layer (AZ4562 standard resist), on top of the Si wafer. The resist functions as an etch mask in the subsequent DRIE process optimized for deep etching [etch: SF$_6$; 230 SCCM (SCCM denotes cubic centimeter per minute)].
minute at STP), \( \text{O}_2:23 \text{ SCCM}, \text{ rf coil: } 2800 \text{ W}, \text{ rf platen: } 19 \text{ W}, \text{ cycle time: } 8 \text{ s}. \) Passivation: \( \text{C}_4\text{F}_8:120 \text{ SCCM}, \text{ rf coil: } 1000 \text{ W}, \text{ rf platen: } 0 \text{ W}, \text{ cycle time: } 5 \text{ s}. \) The window and the backside hole are fabricated in the two first masking steps, and in the case of the substrate wafer, the channel structures are subsequently fabricated in a third masking step. Afterwards, a 110 nm silicon dioxide [\( \text{SiO}_2 \), black in Fig. 2(a)] layer is thermally grown (dry oxidation, \( 1100 \degree \text{C}, 50 \text{ min} \)) on both the substrate and lid Si wafer to prepare the wafers for fusion bonding and to make the channels more hydrophilic. Finally, after removing the \( \text{SiO}_2 \) on the backside of the wafers and inside the CBV, fusion bonding\({}^{30}\) is used to seal the channels in the structured Si substrate wafer either with a borofloat glass wafer or a Si wafer with backside and seal the channels in the structured Si substrate wafer either.

III. EXPERIMENTAL RESULTS AND DISCUSSION

A. Experimental result of the CBV

Characterization of the CBV was divided into three parts. The first part was an extensive investigation of the relation between the diameter of the windowless access hole and the burst pressure. A test liquid consisting of 1 \( \mu \text{m diameter fluorescent labeled polystyrene spheres dispersed in de-ionized water at a } 0.0001 \text{ wt } \% \text{ solid concentration was used. The microspheres were used as marker particles to monitor the fluid flow velocity. No effect of the microspheres on the bursting pressure was observed at this concentration of microspheres nor at the highest concentration tested, } 0.1 \text{ wt } \%. \) The second part of the characterization of the CBV-based devices involved testing the functionality with two samples, relevant for ultrafast time-resolved analysis of chemical and biological species in liquid solution; 8 mM of the highly photoactive platinum compound Tetrais-\( \mu \)-pyrophosphotidilatinate(IΙ) (PtPOP) in \( \text{H}_2\text{O} \) (Ref. 21) and 2, 5, and 10 mM of the well-studied protein Cytochrome-C (Ref. 22) in a dedicated buffer (50 mM Hepes and 150 mM \( \text{NaCl} \) in de-ionized water). The third and final part of the characterization was a vacuum compatibility test to confirm that the device would work in environments below atmospheric pressure.

In all cases 500 \( \mu \text{l} \) of the sample was added to each of the two inlets and capillary forces dragged the sample into the device. Subsequently, an overpressure, supplied from a minidiaphragm vacuum pump (VP 86 with EU-plug, VWR and Bie & Berntsen) and controlled with a multitrust needle valve (EW-06393–60, Cole Parmer), of 3 mbar was applied to the inlets and the established flow was allowed to continue for 15 min in order to secure stability of device and flow. The pressure at the inlets was then increased slowly from 3 mbar until the CBV was observed to burst. For each valve diameter, five to nine chips from the same wafer were tested to provide sufficient statistics on the reproducibility of the results presented in Fig. 3. This figure shows the measured burst pressure as function of valve diameter along with the corresponding theoretical values calculated from Eq. (1). After the initial burst events reported in Fig. 3, the burst pressure was observed to depend critically on cleaning but was generally lower than the initial value. We assign this lowering of burst pressure to the presence of microspheres and other solid contaminants at the transition between the narrow and the wide part of the CBV.

The surface tension in Eq. (1) is set to the value of water on Si at 20 \degree \text{C}, 72.9 mJ/m\(^2\). The contact angle \( \theta_{cb} = \theta_c + \phi_{cb} \) was observed to depend on hole diameter due to the DRIE process of the backside hole. \( \theta_c \) was measured (Krüss DSA100) to be 40.5\(^\circ\) with a standard deviation of 5.7\(^\circ\). The corresponding uncertainty in predicted burst pressure is represented in Fig. 3 by the dashed lines. \( \phi_{cb} \) as determined by scanning electron micrograph (SEM) investigations of split CBVs was determined to depend directly on the hole diameter and to range from 70\(^\circ\) for the largest access holes to 90\(^\circ\) for the smallest holes. Altogether, \( \theta_{cb} \) ranges from 112\(^\circ\) to 132\(^\circ\) in the devices tested in this study, and the burst pressures predicted through Eq. (1) and using these values are indicated by the solid line in Fig. 3.

From Fig. 3, it is evident that the bursting pressure as a function of valve diameter is well described by Eq. (1). From the characterization measurements on the CBV devices, the average flow velocity in the channel was observed to depend linearly on the pressure difference between inlet and outlet as expected for a Poiseuille flow.\(^{23}\) The increase in average velocity per mbar pressure increase was found to be 2 mm/s (s mbar). The maximum average velocity thus ranged from 44 mm/s for the 130 \( \mu \text{m} \) access holes to 540 mm/s for the 10 \( \mu \text{m} \) access holes corresponding to a refresh rate of the measuring volume of 0.3 and 54 kHz, respectively.

It should be noted that the angle of the air-liquid interface of the CBV is strongly dependent on the driving pressure, going from convex to concave with increasing pressure. For applications where refraction effects are of importance, the overpressure can thus be chosen to produce a flat meniscus interface.

In the compatibility test with PtPOP and Cytochrome-C
the CBV did not deviate from the tests with 0.0001 wt % polystyrene microspheres in water presented in Fig. 3. These tests were carried out in an identical fashion but additionally the 500 µl sample from each inlet was collected after passing the chip and from microscope inspections it was verified that it was not absorbed on the inner surfaces of the microfluidic channels. Examples of 2, 5, and 10 mM Cytochrome-C samples in the chip are shown in Figs. 4(b)–4(d), respectively. With respect to chemical stability, the surface material of the channels, SiO₂, is very stable toward biological samples as well as aggressive solvents such as those typically used for nanomaterial synthesis. The current chip design and material choice can therefore be used for most biology and synthesis studies.

Basic vacuum functionality was confirmed using a purpose-built vacuum chamber with liquid connections to the chip. The chip was tested down to chamber pressure 100 mbar with de-ionized water as the test liquid. The results were similar to those presented in Fig. 3.

**B. Experimental result of the x-ray measurements**

To test the proposed sample handling system under realistic operating conditions, a CBV chip with Si lid was mounted at the time-resolved beamline ID09b at the ESRF synchrotron radiation facility in Grenoble using a purpose-built sample chuck with incorporated channels for sample supply to the chip. After preparing the system with a sample solution (water) and connecting it to the flow control system, the access hole on the chip was manually aligned to the incoming laser and x-ray beams using a microscope. The position was subsequently refined using a point detector situated behind (downstream) the chip+holder.

Figure 5 shows the scattering pattern acquired on an area detector (Frelon) placed 10 cm downstream from the laser/x-ray overlap point positioned in the middle of the flow channel. Also shown in this figure are rings denoting values of the scattering angle 2θ. Due to the narrow geometry chosen for the backside hole in the CBV, part of the Si substrate will shadow some parts of the detector. The green, dashed circle denote the point where shadowing due to absorption in Si exceeds 5% at 18 keV, assuming scattering from a point in the center of the channel. It is observed that only the part of the scattering pattern extending up to 2θ=12° [Q = 1.8 Å⁻¹, Q = 4π/λ sin θ(λ = 0.7 Å)] is completely unperturbed by shadowing effects with the present chip geometry. The driving pressure was kept at 3 mbar, corresponding to a flow speed of 6 mm/s (refresh rate=41 Hz). This corresponds to a sample consumption rate of 0.5 ml/h, in good correspondence with observations during the experiments.

Attempts at acquiring a time-resolved signal with a solution of TlPtPOP (Ref. 25) were not conclusive, as irradiation of the stacked/stagnant volume caused significant precipitation of Pt crystallites as well as strong perturbations of the scattering signals due to local heating. However, transient heating of the precipitated crystallites was observed on the subnanosecond time scale, confirming that spatial overlap between laser and x ray was not lost during the experiment.
Both of the above mentioned issues can be overcome by alternative fabrication methods, as described in Sec. IV. The observed issues related to the stagnant volume give rise to considerations regarding chip design and the possibility of introducing thin windows of, e.g., silicon nitride. However, the presence of windows may lead to gradual and irreversible irradiation-induced buildup of contaminants on the window surface, whereas any contaminants in the stagnant volume will eventually be removed through diffusion. Also, and especially important for XFEL applications, at sufficiently high x-ray intensities window damage will be inevitable. With a CBV, we achieve a self-healing liquid membrane, which is not permanently damaged and where x-ray diffraction characteristics do not change over time.

IV. CONCLUSIONS AND OUTLOOK

In the preceding sections, a microfluidic system with an out-of-plane CBV enabling windowless access to a microchannel has been demonstrated. The functionality of the out-of-plane CBV has been demonstrated up to driving pressures of 280 mbar corresponding to a burst pressure of 140 mbar (the CBV is placed in the middle of the microfluidic network), and the bursting pressure has been shown to be in good correspondence with the Young–Laplace equation for a channel with circular cross section. From measurements on fluorescently labeled latex beads in water, the flow velocity in the microfluidic channel has been observed to be well described by the Hagen–Poiseuille equation. One of several possible applications of the investigated microfluidics system is for time-resolved x-ray scattering based on stroboscopic applications of the pump-probe technique. Due to the high beam intensities involved and/or irreversible reactions, sample replacement between successive pump-probe events is often mandatory. For the XFEL sources discussed in Sec. I, the repetition rate covers the range from 10 Hz to 5 MHz. Combining the observed flow rates and access hole diameters, the maximum sample replenishment rate for the system described in this article ranges from 0.3 kHz (140 μm access hole) to 54 kHz (10 μm access hole). In combination with the demonstrated synchrotron beamline feasibility, the windowless microfluidic chip thus presents itself as a candidate sample handling system for several of these large-scale instruments, although reaching the 5 MHz repetition frequency of the Euro XFEL currently seems unrealistic. Turning to sources already in use today, the 1 kHz repetition rate adopted at several facilities is reached with the presently proposed design using access hole diameters below 90 μm. However, if a tapered channel is chosen at the windowless access hole diameters above 90 μm can be achieved. Regarding time resolution and channel depth, current results from LCLS indicate that time resolutions well down into the tens of femtoseconds should be feasible, mandating correspondingly smaller sample thicknesses as discussed in Sec. I. Within the design paradigm presented in this work, channel depths down to 1 μm can be fabricated without any changes to the techniques chosen and without adversely affecting the flow properties of the sample chip.

In situ experiments at ID09b (ESRF) demonstrated that the stagnant volume associated with CBV region was strongly detrimental to chip performance. Also, significant shadowing effects were observed, complicating data analysis for scattering angles exceeding 2θ=12°. These issues could be addressed by replacing the DRIE process with an anisotropic potassium hydroxide (KOH) etch, giving atomically sharp edges with no associated stagnant volume as well as a 34° slope of the access hole, allowing unimpeded collection of scattered x rays up to 2θ 30°. Initial measurements on KOH-etched prototype devices confirmed the basic feasibility of this approach but at the cost of lowered burst pressure, suggesting a combination of KOH and DRIE etch for a final design.

An attractive feature of the proposed system is the very low sample consumption, ml/h, which may be especially relevant for, e.g., protein studies or in case other precious reagents are involved. In combination with straightforward integration of existing lab-on-a-chip technologies, where especially incorporation of optical diagnostics would be a very significant advantage, the proposed microfluidic sample chip offers interesting new experimental possibilities within time-resolved x-ray scattering applications. Furthermore, the windowless design will, together with the vacuum compatibility and the possibility of producing liquid sheets of micrometer thickness, open interesting possibilities for applications in electron scattering and electron microscopy.

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